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Bib Data Sheet

CONFIRMATION NO. 3205

SERIAL NUMBER 09/187,551	FILING DATE 11/05/1998 RULE	CLASS 427	GROUP ART UNIT 1762	ATTORNEY DOCKET NO. AM524R1/T289	
APPLICANTS KATSUYUKI MUSAKA, INBA, JAPAN; SHINSUKE MIZUNO, INBA, JAPAN; ** CONTINUING DATA ***** This application is a REI of 08/259,584 06/14/1994 PAT 5,571,571 which is a CIP of 08/184,331 01/19/1994 ABN ** FOREIGN APPLICATIONS ***** JAPAN 3-145070 06/16/1993					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged		STATE OR COUNTRY JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS 26	INDEPENDENT CLAIMS 5
ADDRESS 32588 APPLIED MATERIALS, INC. 2881 SCOTT BLVD. M/S 2061 SANTA CLARA, CA 95050					
TITLE METHOD OF FORMING A THIN FILM FOR A SEMICONDUCTOR DEVICE					
FILING FEE RECEIVED 1168	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		

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APPLICANT

KATSUYUKI MUSAKA, INBA, JAPAN; SHINSUKE MIZUNO, INBA, JAPAN.

Issue date 11/5/96
Patent 11/5/98

****CONTINUING DOMESTIC DATA*******
 VERIFIED THIS APPLN IS A RE OF 08/259,584 06/14/94 PAT 5,571,571
 WHICH IS A CIP OF 08/184,331 01/19/94 ABN

LOC 150 - p. 1 f. 6
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****371 (NAT'L STAGE) DATA*******
 VERIFIED

****FOREIGN APPLICATIONS*******
 VERIFIED JAPAN 3-145070 06/16/93

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TITLE

METHOD OF FORMING A THIN FILM FOR A SEMICONDUCTOR DEVICE